

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)  <b>PTO Form 1449</b>	Attorney Docket No. 053785-5182	Serial No. <del>Unassigned</del> 10/840240
	Applicants Jin-Ook KIM	
	Filing Date May 7, 2004	Group <del>Unassigned</del> 1709

<b>U.S. PATENT DOCUMENTS</b>
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*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Sub Class	Translation YES NO	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
/S.Y./		Younan XIA, et al. "Soft Lithography." <u>Angew. Chem. Int. Ed.</u> , 1998, pp. 550-575.

Examiner	/Stella Yi/	Date Considered	09/14/2007
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